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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/670,356	09/26/2003	Mutsuko Hatano	520.39728VX1	520.39728VX1 5271	
20457	7590 12/05/2005		EXAM	INER	
ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET			NGUYEN,	NGUYEN, TUAN H	
SUITE 1800	OL VEIVIEEN III STREE		ART UNIT	PAPER NUMBER	
ARLINGTON	VA 22209-3873		2813	<u> </u>	

DATE MAILED: 12/05/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	OK.					
	Application No.	Applicant(s)				
	10/670,356	HATANO ET AL.				
Office Action Summary	Examiner	Art Unit				
	Tuan H. Nguyen	2813				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D  - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period  - Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailin earned patent term adjustment. See 37 CFR 1.704(b).	NATE OF THIS COMMUNICATION  136(a). In no event, however, may a reply be to the second will expire SIX (6) MONTHS from the course the application to become ABANDON	N. imely filed in the mailing date of this communication. ED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 19 S	September 2005.					
	s action is non-final.					
3) Since this application is in condition for allowa	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4)⊠ Claim(s) <u>1-23</u> is/are pending in the application	1.					
4a) Of the above claim(s) is/are withdrawn from consideration.						
5)⊠ Claim(s) <u>16, 17, 19, 21, 23</u> is/are allowed.	• • • • • • • • • • • • • • • • • • • •					
6)⊠ Claim(s) <u>1-15,18,20 and 22</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/o	8) Claim(s) are subject to restriction and/or election requirement.					
Application Papers						
9)☐ The specification is objected to by the Examiner.						
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).						
a) All b) Some * c) None of:						
1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No						
3. Copies of the certified copies of the priority documents have been received in this National Stage						
application from the International Bureau (PCT Rule 17.2(a)).						
* See the attached detailed Office action for a list of the certified copies not received.						
Attachment(a)	•					
Attachment(s)  1) Notice of References Cited (PTO-892)	4) Interview Summar	v (PTO-413)				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail [	Date				
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08	,	Patent Application (PTO-152)				
Paper No(s)/Mail Date  U.S. Patent and Trademark Office	6)					
	ction Summary P	art of Paper No./Mail Date 20051129				

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#### **DETAILED ACTION**

### Allowable Subject Matter

The indicated allowability of claim 18 is withdrawn in view of the newly discovered reference(s) to Grigoropoulos et al.. Rejections based on the newly cited reference(s) follow.

#### Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-9, 13-15, 18, 20, 22 are rejected under 35 U.S.C. 102(e) as being anticipated by Grigoropoulos et al. (U.S. 6,451,361).

Grigoropoulos et al., figs. 1-13 and related text on col. 1-12 discloses the claimed method for producing an image display device including a thin film transistor comprising growing semiconductor crystal grains in a transverse direction in a semiconductor film by modulating a continuous wave laser in time into a pulse laser beam, and irradiating it on the semiconductor film (as shown in figs. 1-7 and related text con col. 1-5).

With respect to claims 1,18, 22, see particularly fig. 12 and related text on col. 8 for a process for producing an TFT in image display device including a channel region

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1206 formed in the semiconductor film between the first and second charge transmitting and receiving means 1202, 1204 wherein the semiconductor film is essentially comprised of crystal grains having an axis in a longitude direction of 45° or less with respect to a direction F for connecting the first and second charge transmitting and receiving means in the channel region 1206 by growing semiconductor crystal grains in a transverse direction in a semiconductor film by modulating a continuous wave laser in time into a pulse laser beam, and irradiating it on the semiconductor film.

With respect to claim 2, see fig. 12 and text on col. 8, lines 50-60 for the scan direction.

With respect to claims 3, 4, col. 9, lines 44-46 disclose the use of laser beam to transform the semiconductor material which inherently includes amorphous silicon or polysilicon.

With respect to claims 5-7, see col. 5, lines 37-40, col. 11, lines 12-14 for the pulse width and pulse density of the pulse laser beam.

With respect to claims 8-9, figs. 3A-3B show pulse shapes and beam intensity; figs. 9, 10A-10 and text on col. 6 for the modulation according to an external voltage of a continuous wave Ar+ laser 132 in time into a pulsed laser beam.

With respect to claims 13-14, fig. 12 shows the scan direction, and the crystal grain are grown in a strip shape following the direction of the scan.

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With respect to claim 15, the charge transmitting and receiving means are source and drain regions 1202, 1204 of the thin film transistor as shown in fig. 12, and text on col. 8.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Grigoropoulos et al. (U.S. 6,451,361).

Grigoropoulos et al., figs. 1-13 and related text on col. 1-12 disclose substantially the claimed method for producing an image display device except silent about the kind of laser device and alignment pattern. Note on col. 11, third paragraph for the suggestion of beam alignment.

Since laser source such as solid state laser device or laser diode, and mark alignment are well-known and commercial available, it would have been obvious to those skilled in the art at the time the invention was made to have used solid state laser device as a laser beam source for modulating the continuous wave into the pulsed laser beam, and alignment pattern for irradiating the semiconductor thin film as disclosed by Grigoropoulos et al. in order to improve the crystallinity, uniformity, repeatability of the crystallized thin film.

Claims 16, 17, 19, 21, 23 are allowed.

Response to Arguments

Applicant's arguments with respect to claims 1-15, 20 have been considered but are most in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tuan H. Nguyen whose telephone number is 571-272-1694. The examiner can normally be reached on 9AM-5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Tuan H. Nguyen
Primary Examiner
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